

TECHNICAL SPEC FOR Wet processing system

System Model:

Akrion REARMOUNT

Wafer size: 6 inch

Application:

Process flow:HF, DI, HNO3, IPA

Front- or rear-mount: rear

Process Robot End-Effector:

Controller: control zone main components pneumatic solenoid panel, heated tank control unit, digital I/O boards (OPTO22)

Transfer robot: robot transfer arm, free standing unit

Common I/O Station: separate

Wafer transfer system: No

Dual buffer queues:

PFA Cassettes: yes

Configuration of each wet process modules:

Tank 1 & 2: not used

Tank 3 HF

Tank 4: DI-water

Tank 5, 6 & 7 not used

Tank 8: HNO3, HF and DI-water

Chemacoustic dryer IPA & DIW

Pumps:

SECS: yes

Vintage:

Missing parts:

Defected parts:

Software: windows

Operating system: 386 computer /Akrion

Photos to Collect

- All 4 sides
- Process modules
- Control panel
- Robots
- Loaders
- Chemical cannisters (close-up on chemicals)
- Gauges/Valves
- Exhaust pipes
- Pumps
- Inside all cabinets
- Serial plate
- Spare parts, manuals (if any)